**PATENT** 

Attorney Docket No. SAM-134

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

4

Applicant(s):

Jae-Hoon Lee, et. al.

Filing Date:

Herewith

Title:

SEMICONDUCTOR DEVICE WIRING AND METHOD OF

MANUFACTURING THE SAME

## CERTIFICATE OF MAILING UNDER 37 C.F.R.§ 1.10

"Express Mail" Mailing Label Number EL681163277US I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated below and is addressed to BOX PATENT APPLICATION, Assistant Commissioner for Patents, Washington, DC 20231.

**BOX PATENT APPLICATION** 

**Assistant Commissioner for Patents** Washington, DC 20231

payment of the issue fee)

a.	INFORMATION DISCLOSURE STATEMENT				
Sir:	This 1	Information Disclosure Statement is submitted:			
[]	under 37 CFR 1.129(a), or (First/Second submission after Final Rejection)				
[X]	under 37 CFR 1.97(b), or (Within three months of filing national application; or date of entry of the national stage in international application; or before mailing date of first office action on the merits, whichever occurs last)				
[]	under 37 CFR 1.97(c) together with either:				
	[]	a Certification under 37 CFR 1.97(e), as checked below, or			
	[]	a \$240.00 fee under 37 CFR 1.17(p), or (After the 37 CFR 1.97(b) time period, but before final action or notice of allowance, whichever occurs first)			
[]	under 37 CFR 1.97(d) together with:				
	[]	a Certification under 37 CFR 1.97(e), as checked below, and			
	[]	a petition under 37 CFR 1.97(d) (2), and			
	[]	a \$130.00 petition fee set forth in 37 CFR 1.17(i). (Filed after final action or notice of allowance, whichever occurs first, but before			

		Jae-Ho lerewith	on Lee, et. al.			
Certification Under 37 1.97(e)						
	-		Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office In a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.			
			No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign application or, to the knowledge of the undersigned, after making reasonable inquiry, was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.			
Enclos	sed here	with is f	Form PTO-1449:			
[X]	Copies of cited references are enclosed.					
[]	Copies of cited references are enclosed except those entered in prior application, U.S. Serial No, and references that are not required to be submitted under 37 CFR 1.98.					
[]	The listed references were cited in a counterpart foreign application.					
Concis	se Expla	anation F	Requirement (non-English references):			
[ ] The "concise explanation" requirement under 36 CFR 1.98(a)(3) for referencesis satisfied by:						
	[]	the exp	lanation provided on the attached sheet.			
	[]	the exp	lanation provided in the Specification.			
	[]	abstrac	t.			
	It is red	quested	the information disclosed herein be made of record in this application.			
Metho	d of pay	ment:				
	Enclosed is a check in the amount of					

Applicant(s): Jae-Hoon Lee, et. al. Filing Date: Herewith				
[]	Please charge Deposit Account of 19-0079 in the amount of			
[]	Two duplicate copies of this Statement are enclosed.			
[X]	Please charge any deficiency in fees and credit any overpayment to Deposit Account No. 19-0079.			

Date Occurred 15, 2000
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Respectfully submitted,

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